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	Application No.	Applicant(s)	/ 110
Notice of Allowability	10/623,581	KOBORI ET AL.	
	Examiner	Art Unit	
	Stanetta D. Isaac	2812	
The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS (herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIG	OR REMAINS) CLOSED in this a or other appropriate communication GHTS. This application is subject and MPEP 1308.	pplication. If not included on will be mailed in due co	ourse. THIS
1. A This communication is responsive to the RCE filed on 12/05	<u>5/05</u> .		
2. ☑ The allowed claim(s) is/are <u>16-36 and 46-60</u> .			
<ol> <li>Acknowledgment is made of a claim for foreign priority und</li> <li>a)                All b)              Some* c)              None of the:         </li> <li>1.              Certified copies of the priority documents have</li> <li>2.              Certified copies of the priority documents have</li> <li>3.              Copies of the certified copies of the priority documents have</li> <li>International Bureau (PCT Rule 17.2(a)).</li> <li>* Certified copies not received:</li> </ol>	been received. been received in Application No		n from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" of noted below. Failure to timely comply will result in ABANDONMETHIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the requi	rements
<ol> <li>A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which gives</li> </ol>	ted. Note the attached EXAMINEF s reason(s) why the oath or declar	R'S AMENDMENT or NO ation is deficient.	TICE OF
<ol> <li>CORRECTED DRAWINGS ( as "replacement sheets") must (a) including changes required by the Notice of Draftspersor 1) hereto or 2) to Paper No./Mail Date</li> <li>(b) including changes required by the attached Examiner's Paper No./Mail Date</li> <li>Identifying indicia such as the application number (see 37 CFR 1.8 each sheet. Replacement sheet(s) should be labeled as such in the deposed attached Examiner's comment regarding REQUIREMENT F</li> </ol>	on's Patent Drawing Review (PTC Amendment / Comment or in the ( (4(c)) should be written on the drawing header according to 37 CFR 1.121 it of BIOLOGICAL MATERIAL	Office action of ings in the front (not the back).  Must be submitted. No	•
<ul> <li>Attachment(s)</li> <li>1.  Notice of References Cited (PTO-892)</li> <li>2.  Notice of Draftperson's Patent Drawing Review (PTO-948)</li> <li>3.  Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date 12/05/05</li> <li>4.  Examiner's Comment Regarding Requirement for Deposit of Biological Material</li> </ul>	6. ☐ Interview Summary Paper No./Mail Da 7. ☐ Examiner's Amend 8. ☐ Examiner's Statem 9. ☐ Other	ate ment/Comment	ance
	T	C 2800, AU 2812	

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## **EXAMINER'S AMENDMENT/COMMENTS**

An examiner's amendment/comments to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

## Continued Examination Under 37 CFR 1.114

A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 12/05/05 has been entered.

## Information Disclosure Statement

The information disclosure statement (IDS) submitted on 12/05/05 was filed after the mailing date of the Office Action on 7/13/05. The submission is in compliance with the provisions of 37 CFR 1.97. Accordingly, the information disclosure statement is being considered by the examiner.

## REASONS FOR ALLOWANCE

The following is an examiner's statement of reasons for allowance:

The closest prior art of record, Matsumoto US Patent 5,396,084 alone or in combination of, Matsumoto US Patent 5,396,084 in view of Iwanaga et al., US Patent 5,932,484 in further view of Shannon US Patent 5,466,617, fails to show the following steps of:

Pertaining to independent claims 16, 22 and 28, wherein the active matrix circuit includes "forming an interlayer insulating film comprising a silicon nitride layer and a silicon oxide layer over said semiconductor layer by plasma CVD, said silicon nitride layer and said silicon oxide layer formed over said gate electrode and said semiconductor layer; and forming a conductive (multi-layer film, for claim 22) layer comprising titanium and aluminum over said interlayer insulating film," that has both the silicon nitride layer and the silicon oxide layer.

Pertaining to independent claims 46, 51, and 56, wherein the active matrix circuit includes "forming a first interlayer insulating film comprising a silicon nitride layer and a silicon oxide layer over said semiconductor layer by plasma CVD, said silicon nitride layer and said silicon oxide layer formed over said gate electrode and said semiconductor layer; forming a conductive layer comprising a titanium and an aluminum over said first interlayer insulating film," wherein the first interlayer insulating film has both the silicon nitride layer and the silicon oxide layer.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Stanetta D. Isaac whose telephone number is 571-272-1671. The examiner can normally be reached on Monday-Friday 9:30am -6:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael Lebentritt can be reached on 571-272-1873. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Stanetta Isaac Patent Examiner December 6, 2005

> LYŇNE A. GURLE: RIMARY PATENT EXAMINER TC 2800, AU 2812